

# Accelerating Interface Science Through NREL's New Electron Microscopy Suite

Steven R. Spurgeon

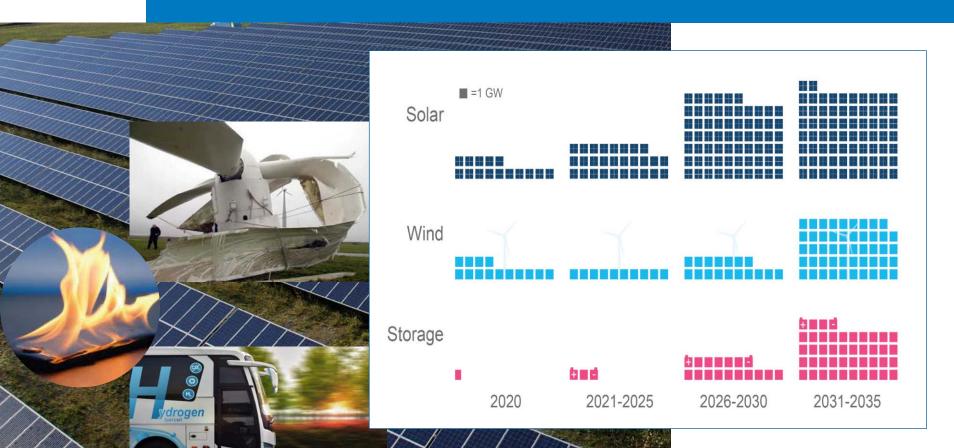
Senior Materials Data Scientist Analytical Microscopy and Imaging Sciences July 28<sup>th</sup>, 2024







# Our Mission: Clean Energy Generation & Storage





### New Capabilities for Multiscale Electron Microscopy







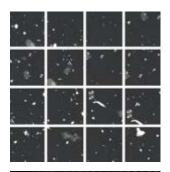




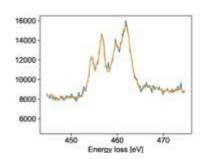


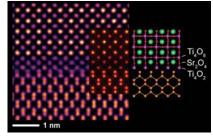


# **Toward Artificial Intelligence Guided Interface Science**







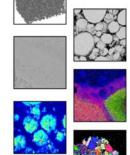






### New Capabilities for Multiscale Electron Microscopy

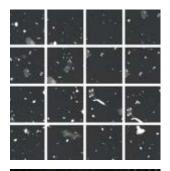


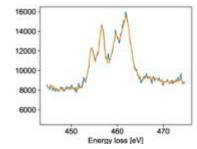




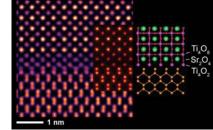


# **Toward Artificial Intelligence Guided Interface Science**

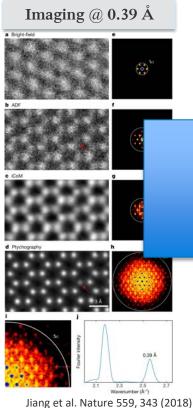




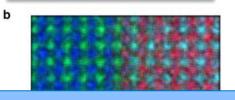




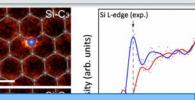




Composition @ Atomic



Bonding @ near Atomic Resolution

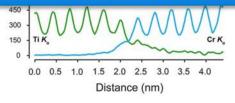


Intensity (arb. 100 105 110 115 120 Energy Loss (eV)

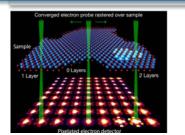
Si L-edge (sp<sup>3</sup>)

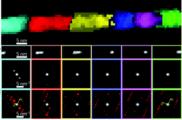
hys. Rev. Lett. 109, 206803 (2012)

## Why electron microscopy? Local, direct analysis down to the atomic scale



Spurgeon et al. Microsc. Microanal. 23, 513 (2017)





ing @ 2 nm

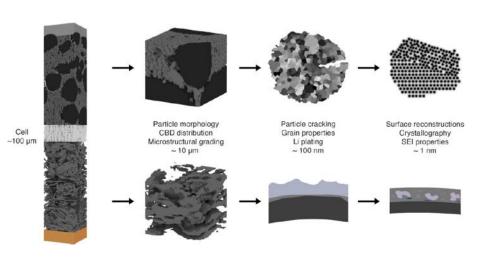
Ophus et al. Microsc. Microanal. 25, 563 (2019)

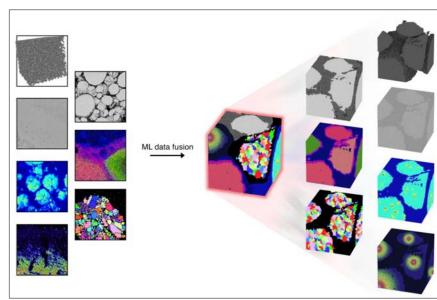
Londoño-Calderon et al. Nanoscale. 13, 9606 (2021)





### Multimodal Microscopy for 3D Understanding of Systems/Materials



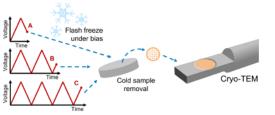


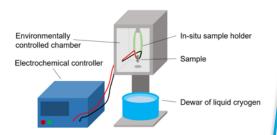
Finegan et al., ACS Energy Lett. 7 (12), 4368 (2022)

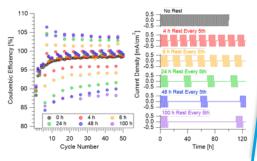




# Operando Electrochemical Freezing Cryo EM



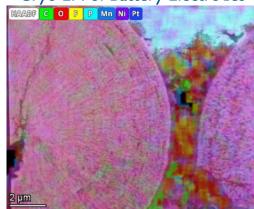


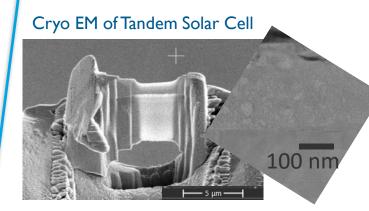


### Unique Value

- Freeze-in 'active' biased states for interfacial analysis
- Cryogenic state enables high-resolution structural and chemical mapping of beam sensitive interfaces
- First demonstration from system-level materials, of an entire coin cell

Cryo EM of Battery Electrodes





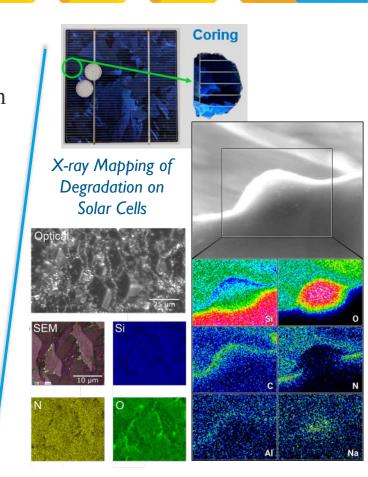




Tescan Solaris Ga-FIB
10's µm cross-sectional milling

### Unique Value

- Precision milling with ion beam for site-specific cross-sectional imaging and mapping
- Cryogenic state enables sample preparation of beam sensitive interfaces
- Cryogenic preparation of samples for scanning transmission electron microscopy



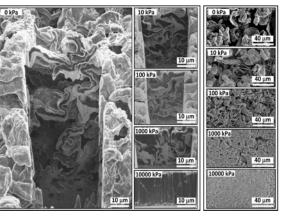




Helios Plasma FIB
100's μm cross-sectional milling

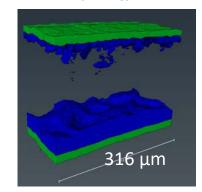
### Unique Value

- Large-area milling with various ion beams for sitespecific cross-sectional imaging and mapping
- Cryogenic state enables sample preparation of beam sensitive interfaces for scanning transmission electron microscopy
- Slice-n-view allows 3D reconstruction over largeareas of composites



Harrison et al., ACS Appl. Mater. Interfaces 13, 31668 (2021)

#### Li Metal Morphology for Batteries



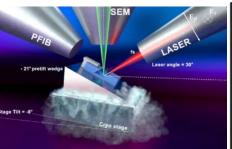
R. Gannon et al., (2024) In Preparation





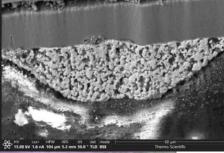


Helios Laser Plasma FIB
10 – 4,000 um cross-sectional milling
fs laser mills 15,000x faster than Gaion FIB









#### Unique Value

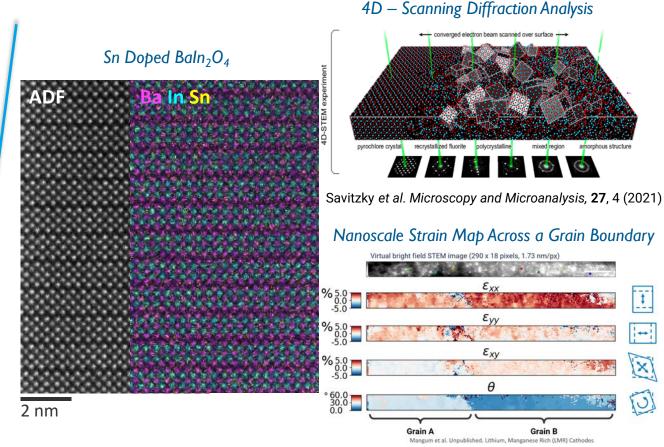
- System-level milling fslaser and ion beams for site-specific crosssectional imaging, compositional mapping, and 3D reconstructions
- Cryogenic state enables sample preparation of beam sensitive materials







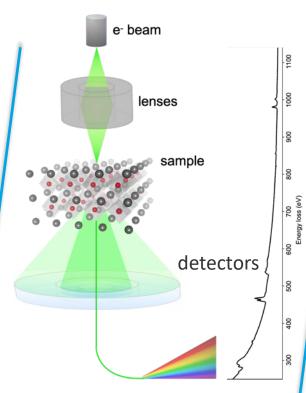
Thermo Fisher Spectra 200
Atomic-scale imaging,
compositional, and strain analysis



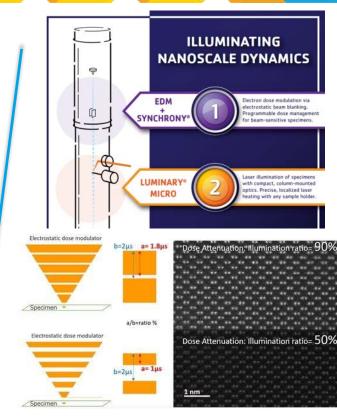




JEOL GrandARM 2
Atomic-scale Imaging and
In-situ Reaction Monitoring



 High-speed imaging and in-situ spectroscopy (valence states & bonding)



Dose control for beam sensitive materials & light-induced reactions



# New Capabilities for Multiscale Electron Microscopy











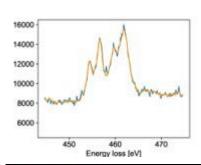


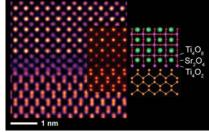


# **Toward Artificial Intelligence Guided Interface Science**





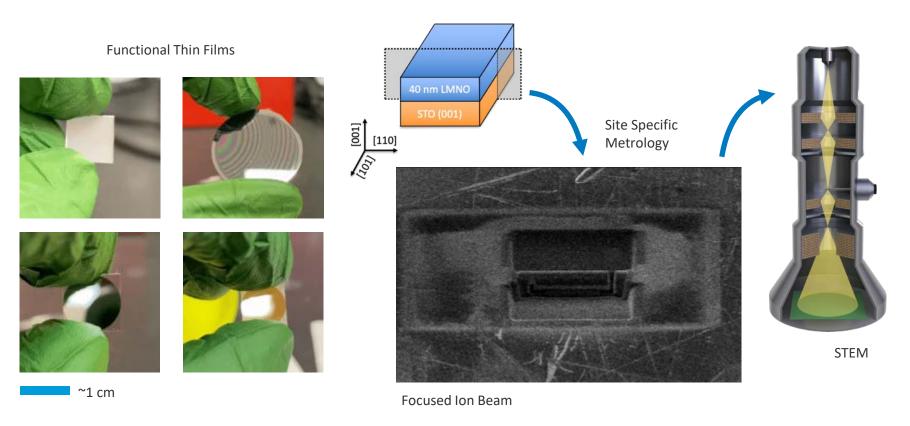






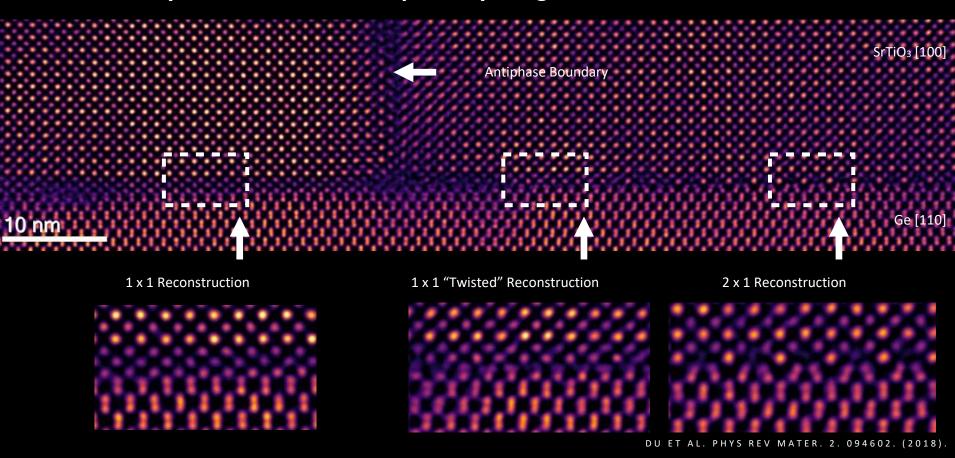


#### Understanding synthesis products requires direct local probes of structure and chemistry.



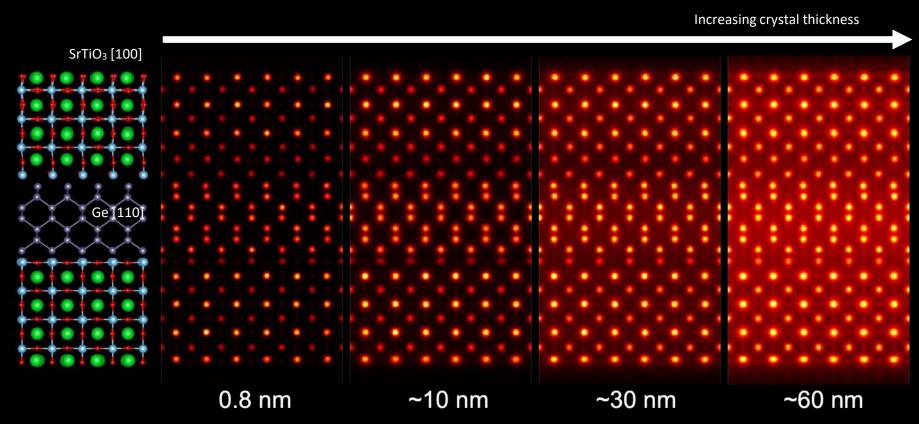


## We can directly resolve interfaces in epitaxially integrated oxides and semiconductors.





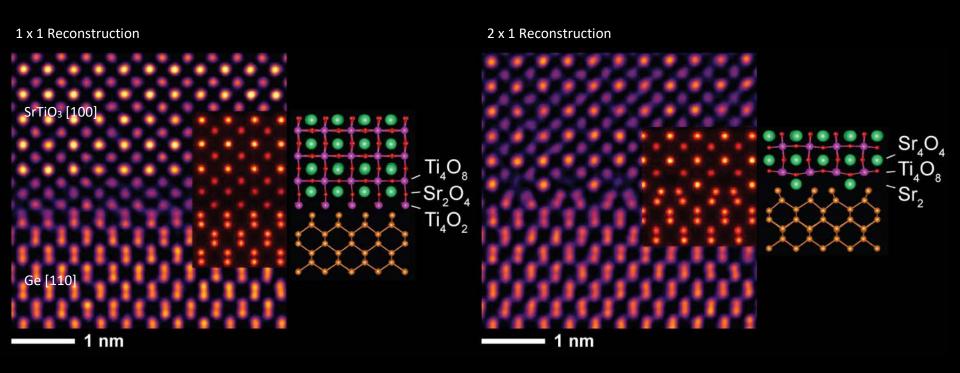
## We can interpret such interfaces through image simulations based on atomistic models.







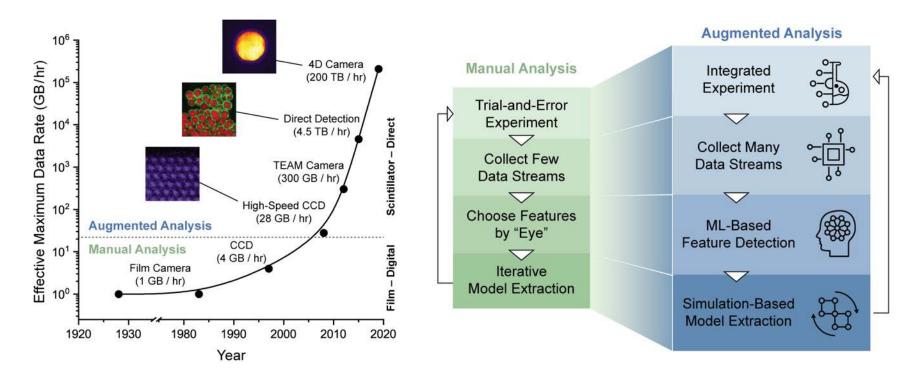
This approach allows us to better understand interface reconstructions, defects, and intermixing that affect properties and performance.







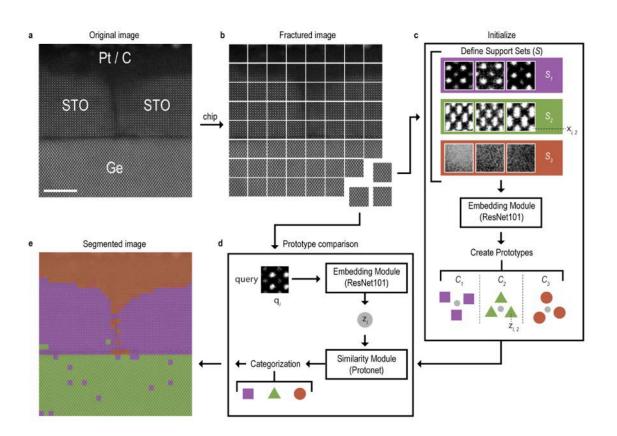
# However, to build even more accurate models for synthesis and degradation we must make sense of large, multi-modal data.



18



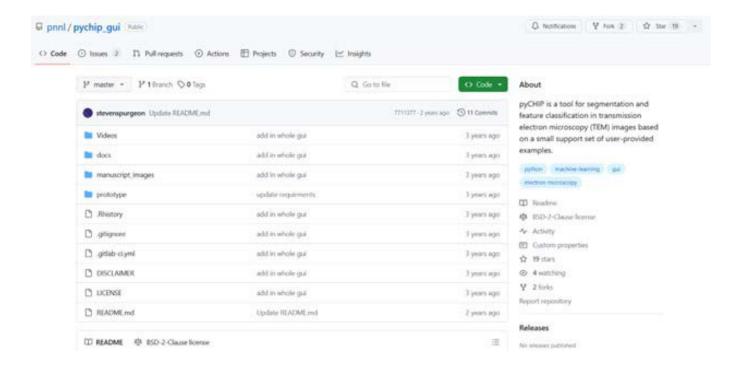
We have developed few-shot machine learning models that allow us to rapidly build statistical models for atomic motifs and defects.







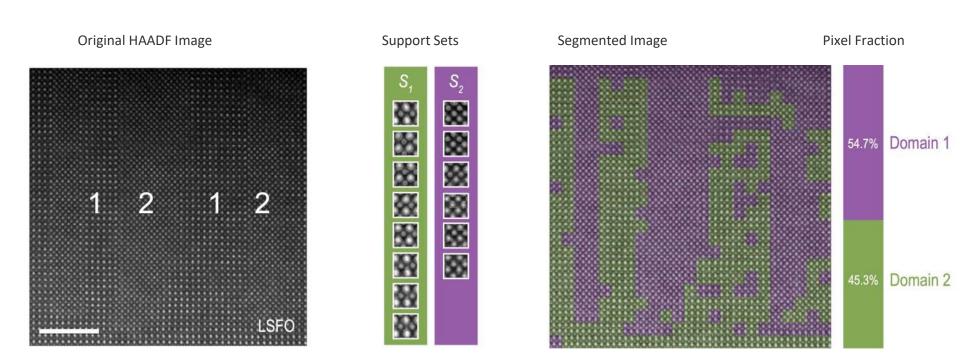
#### Scientists can rapidly train an ML model through simple graphical user interfaces.







#### We classify complex synthesis products and degradation of materials microstructures.





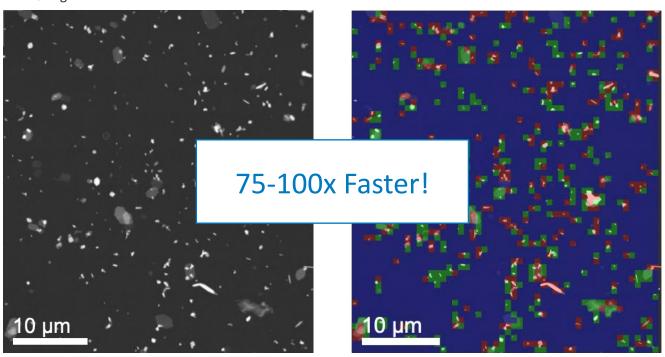
Manual Analysis

10 minutes



#### We can quickly and reproducibly extract microstructural descriptors by task.

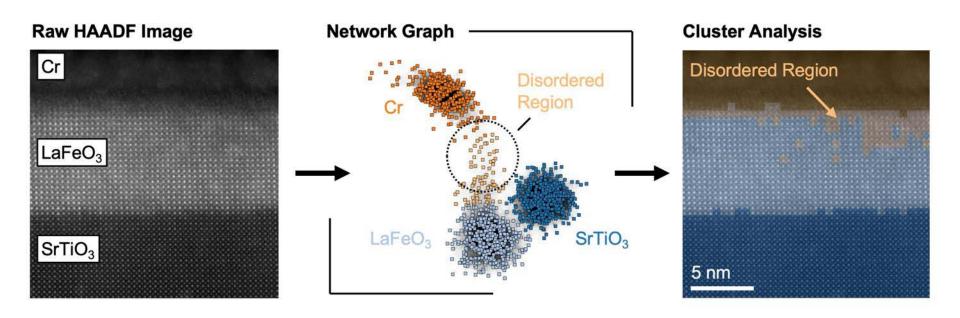
MoO<sub>3</sub> Organic Photovoltaic Precursor



Few-Shot Task 2 8 seconds

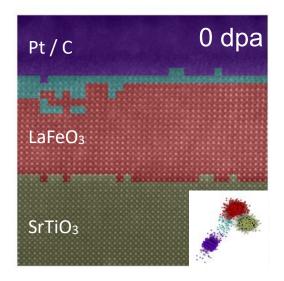


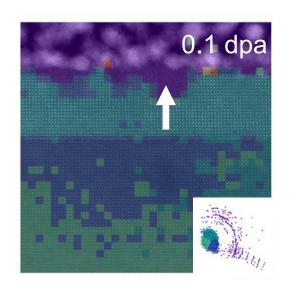
We can describe degradation signatures in an unsupervised manner using graph neural network models, informing more accurate statistical models.

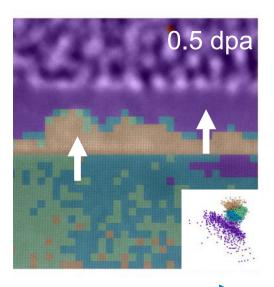




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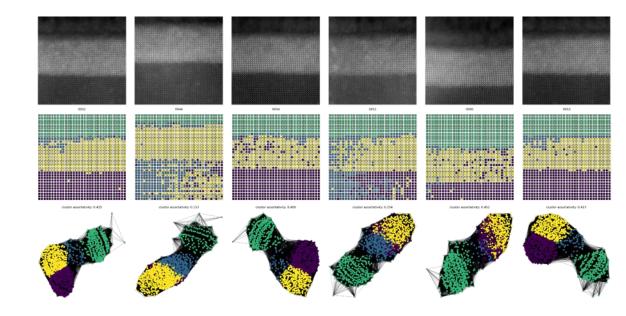
**Increasing Dose** 



ARTIFICIAL INTELLIGENCE-GUIDED
TRANSMISSION ELECTRON MICROSCOPE
(AUTOEM)



Through these approaches, we can curate large libraries of statistical defect information across length scales to inform properties and performance.



NREL is advancing PV interface science through new world-class instrumentation and the development of Al-guided materials science workflows.

# For more information, visit: https://tinyurl.com/z8ryk4y3



NREL/PR-5K00-90723

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